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Zhao et al.

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(54) **INTERPOSER PACKAGE-ON-PACKAGE STRUCTURE**

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(21) Appl. No.: **14/031,000**

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H01L 23/48 (2006.01)
H01L 23/00 (2006.01)

(52) **U.S. Cl.**
CPC ***H01L 24/29*** (2013.01); ***H01L 24/83*** (2013.01)

(58) **Field of Classification Search**
CPC H01L 2924/01079; H01L 2924/01005; H01L 2924/01029; H01L 2924/01013; H01L 2924/14
USPC 257/686, 778, 783, 787; 438/108, 112, 438/118, 127
See application file for complete search history.

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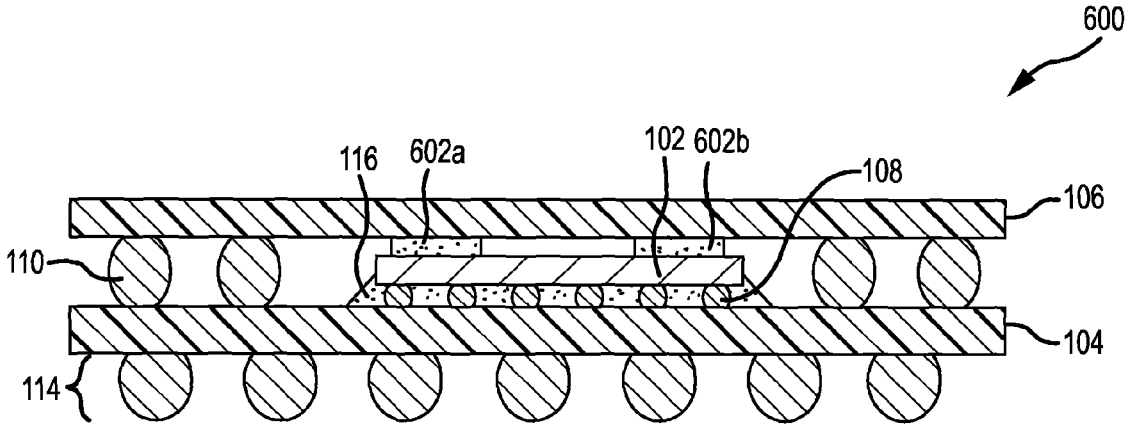
(57) **ABSTRACT**

An integrated circuit (IC) package includes an IC die having a first surface and a second surface opposite of the first surface. The IC package includes first contact members coupled to the second surface of the IC die. The IC package includes a bottom substrate having a first surface and a second surface opposite of the first surface, where the first surface of the bottom substrate is coupled to the second surface of the IC die via the first contact members. The IC package includes an interposer substrate coupled to the first surface of the IC die via an adhesive material, where the adhesive material is disposed on at least a surface of the interposer substrate. The IC package includes second contact members coupled along a periphery of the interposer substrate, where the interposer substrate is coupled to the first surface of the bottom substrate via the second contact members.

22 Claims, 14 Drawing Sheets



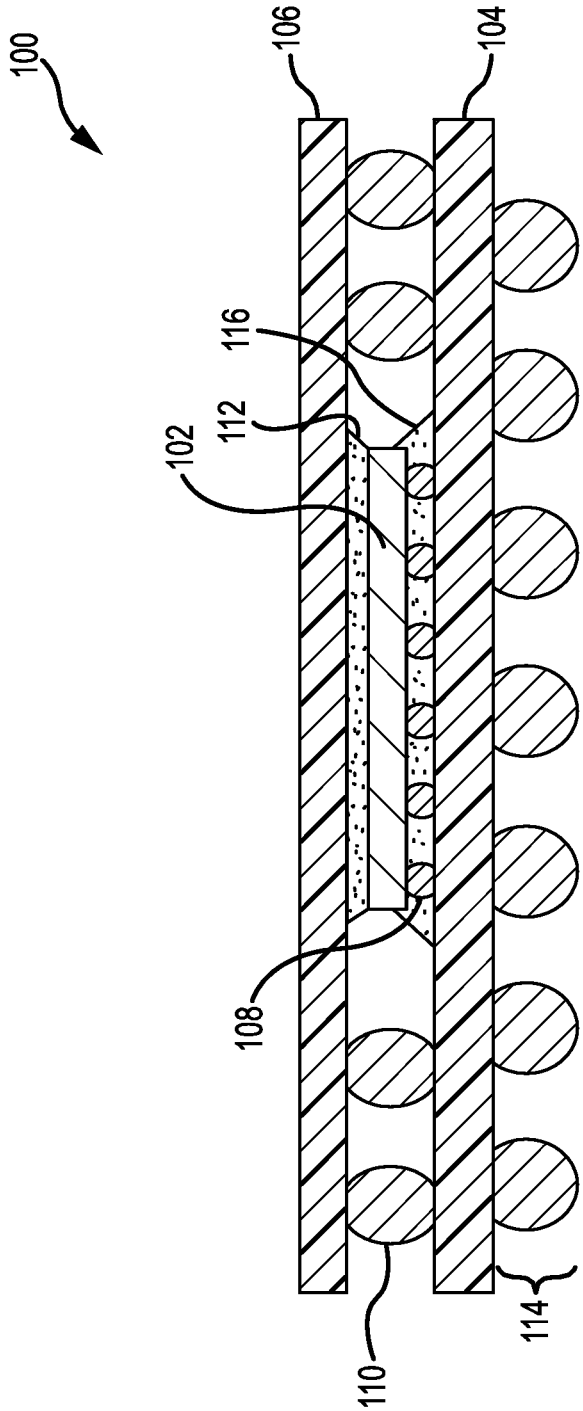


FIG.1

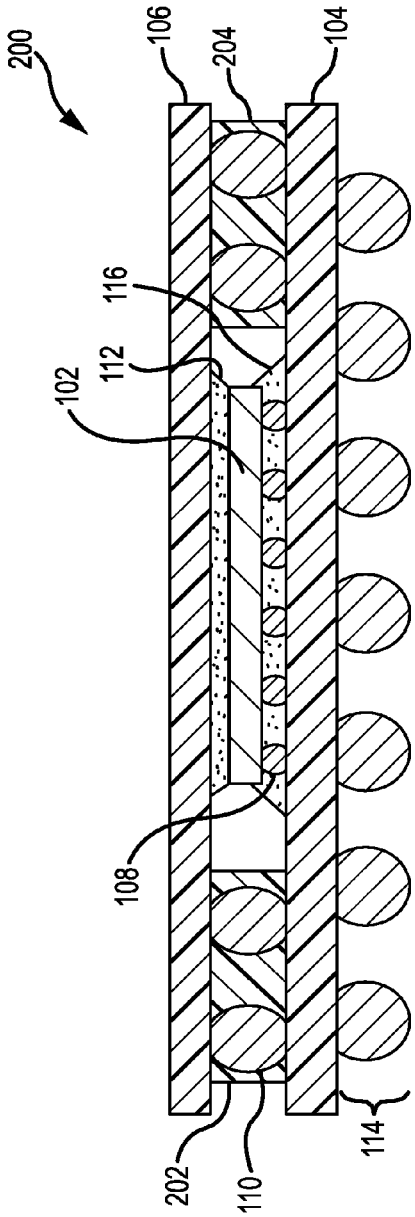
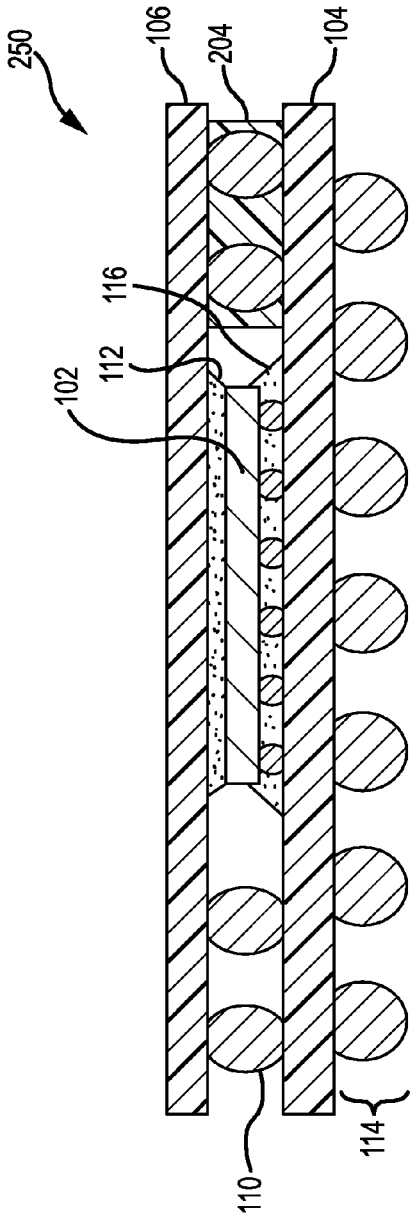

200
106
204
104
116
112
102
108
202
110
114

FIG.2A


250
106
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110
114

FIG.2B

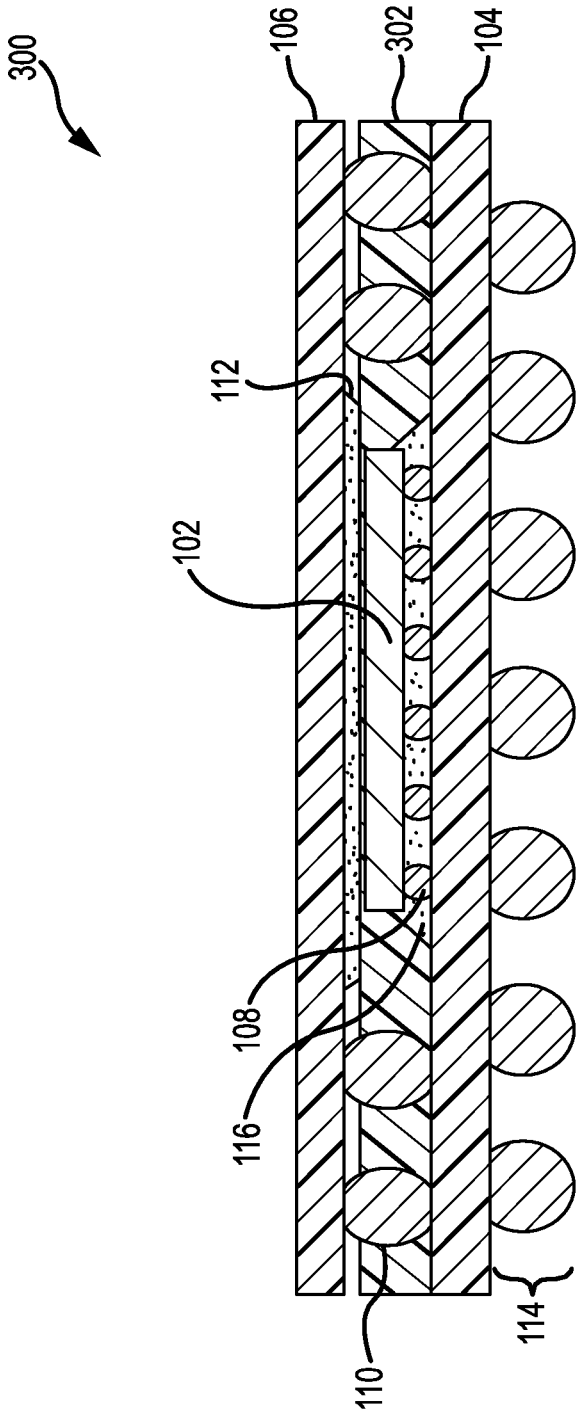


FIG.3

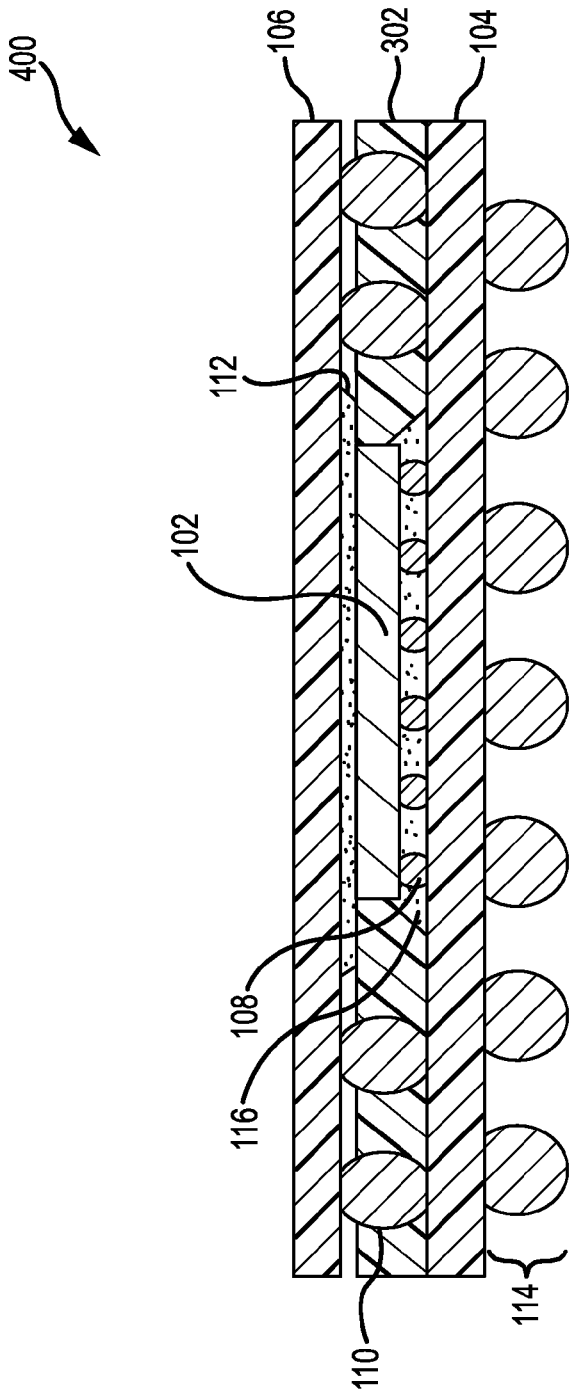


FIG.4

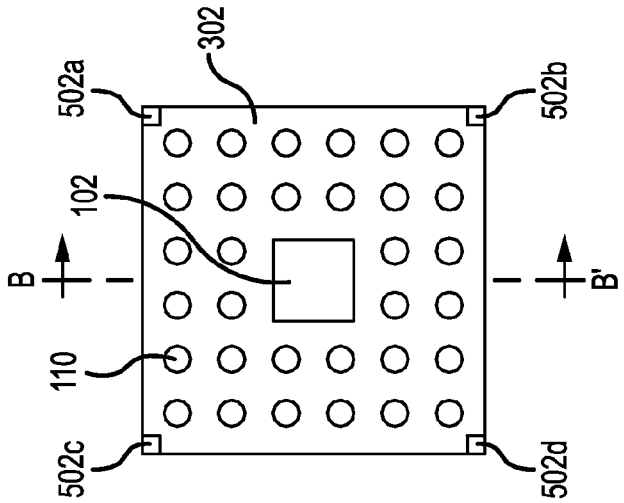
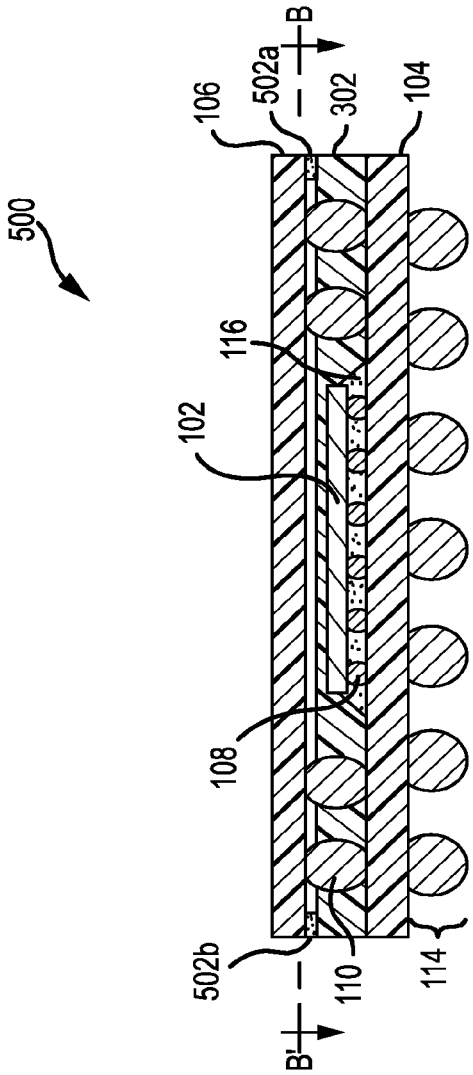

302
502a
502b
102
B
B'
110
502c
502d

FIG.5B


500
B
502a
106
302
104
116
102
108
502b
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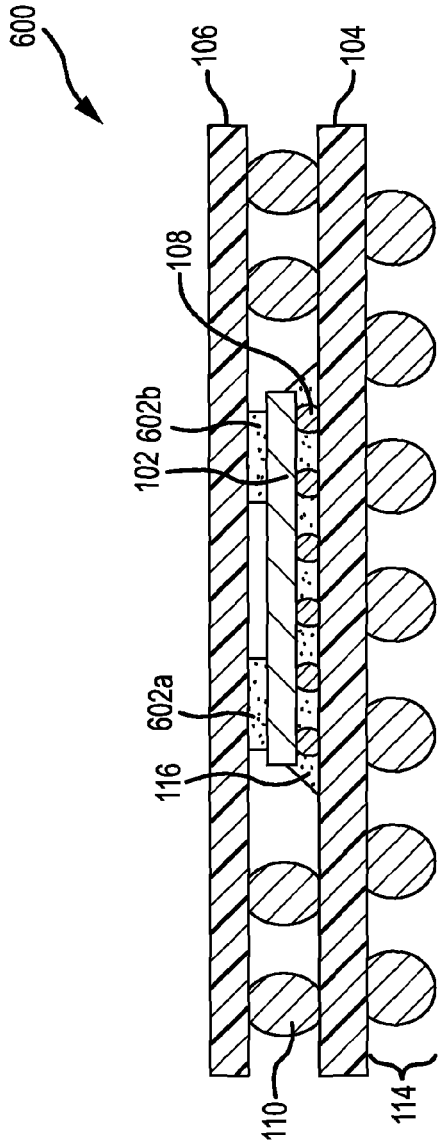
114
B'

FIG.5A


600
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104
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602b
602a
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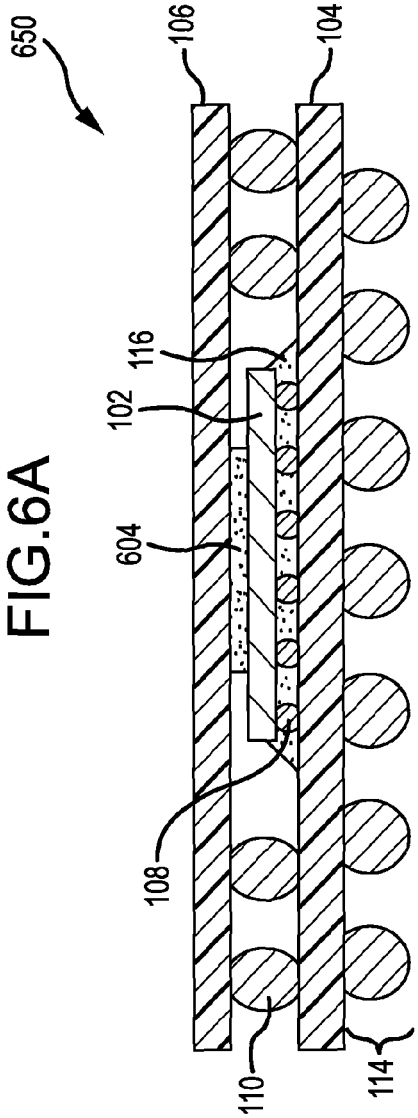
110
114

FIG.6A


650
106
104
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102
604
108
110
114

FIG.6B

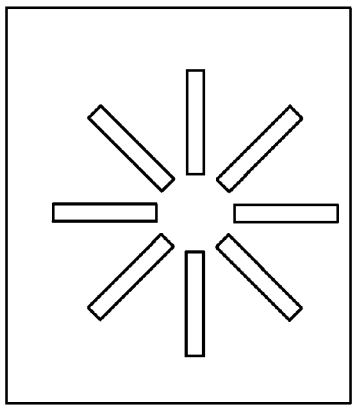


FIG.7B

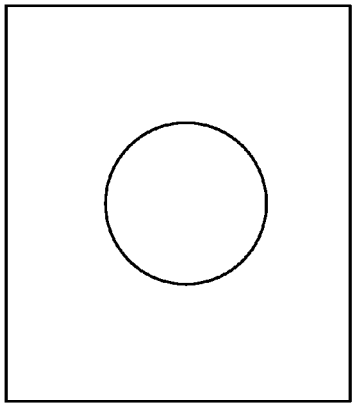


FIG.7D

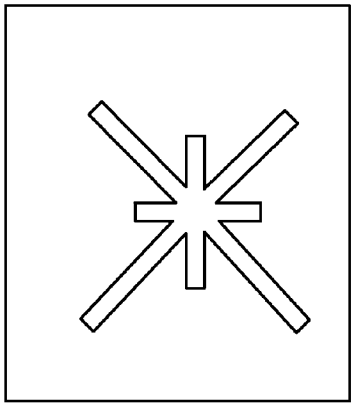


FIG.7A

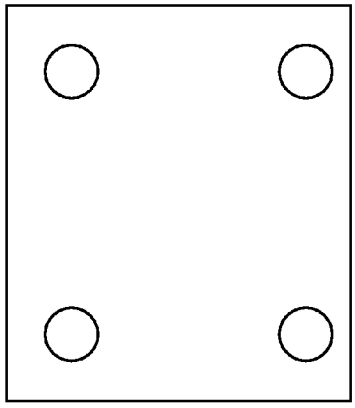


FIG.7C

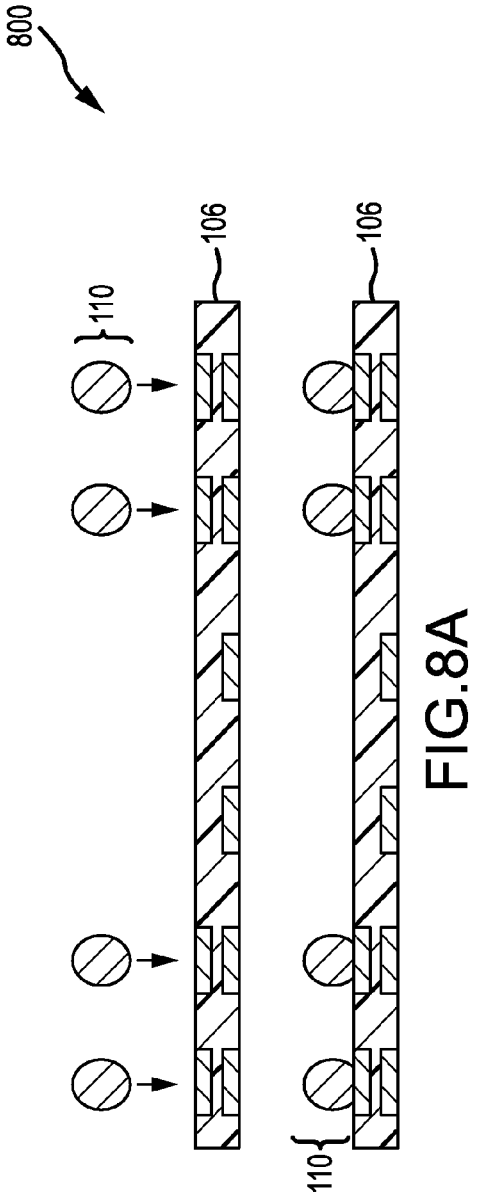


FIG.8A

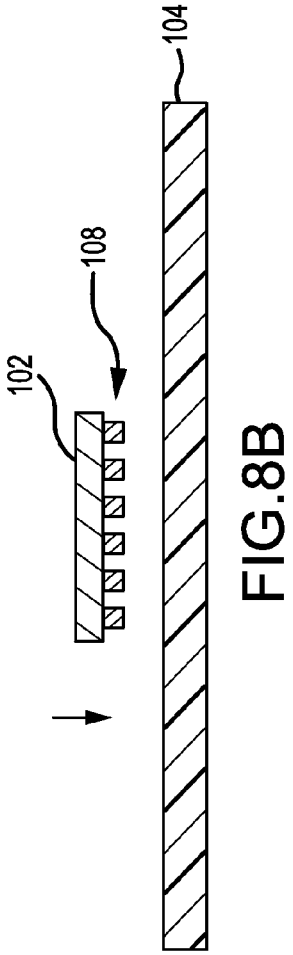


FIG.8B

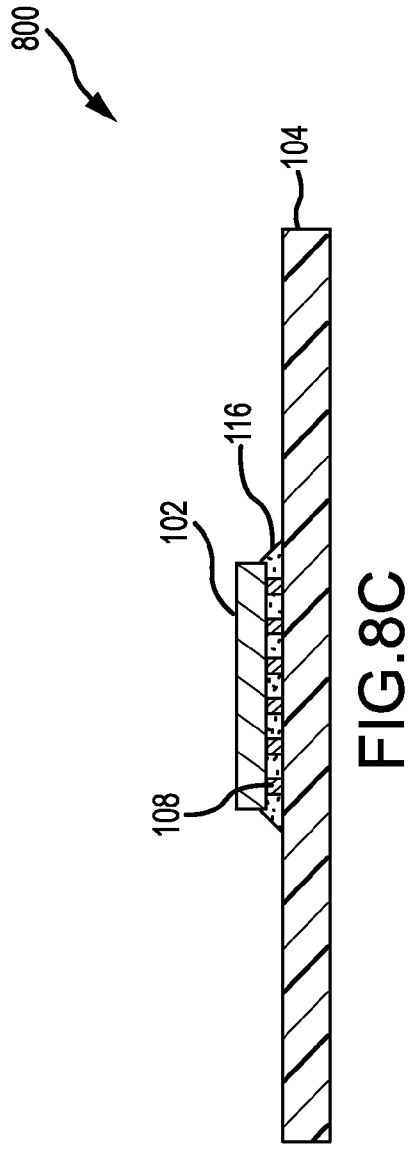


FIG.8C

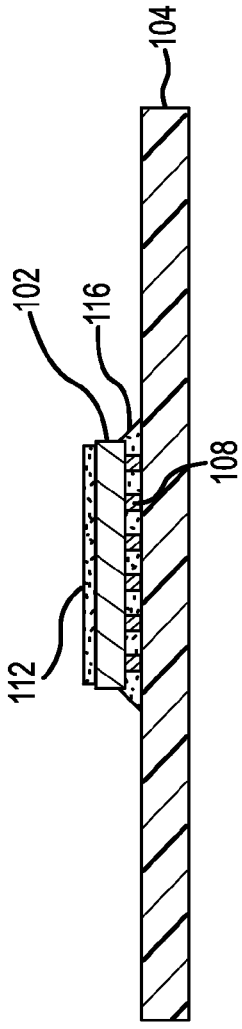
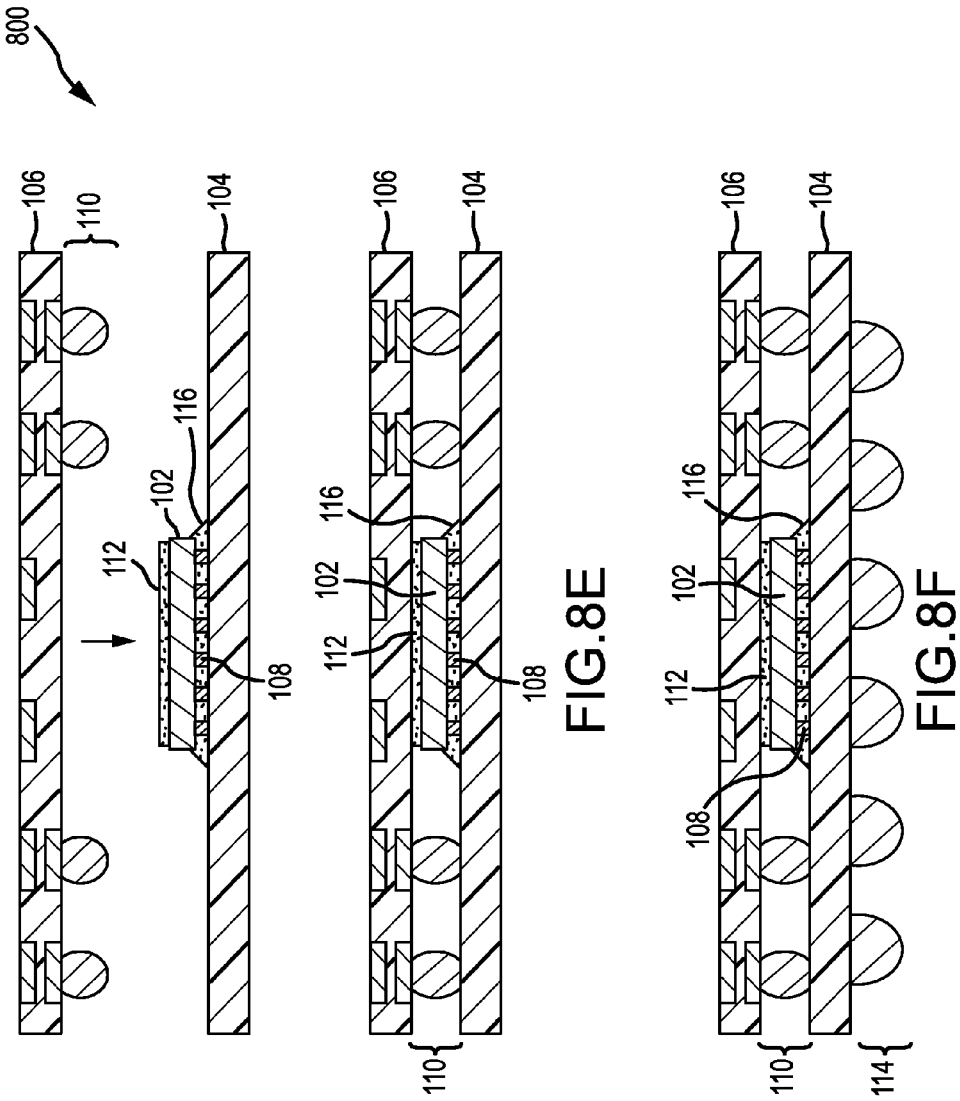


FIG.8D


800
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110
104
116
102
112
108
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114

FIG.8E

FIG.8F

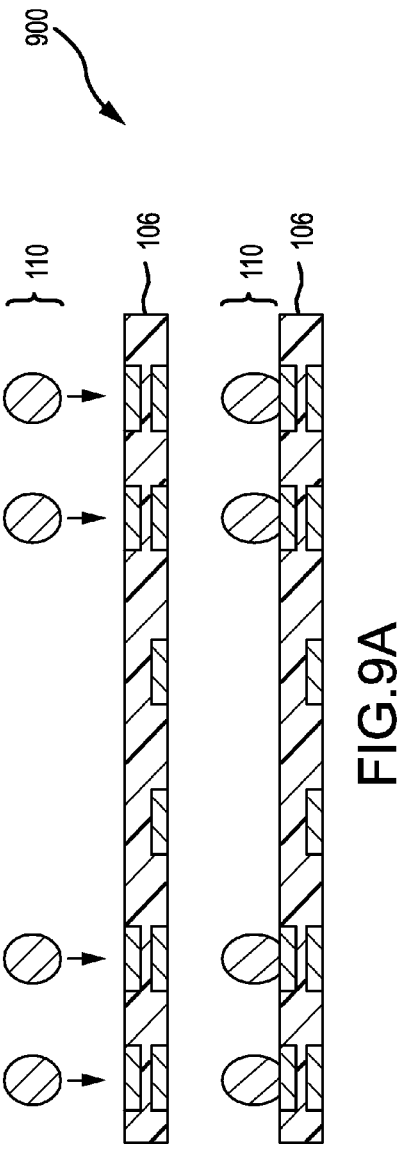


FIG.9A

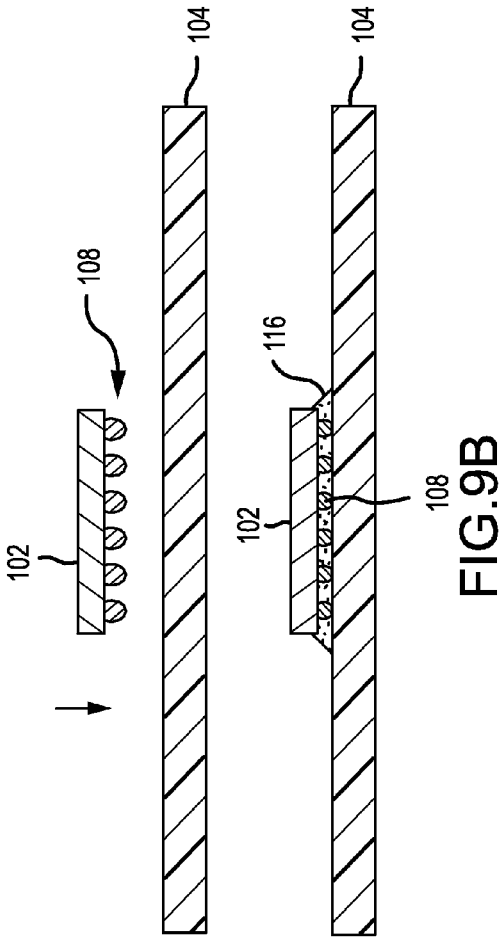


FIG.9B

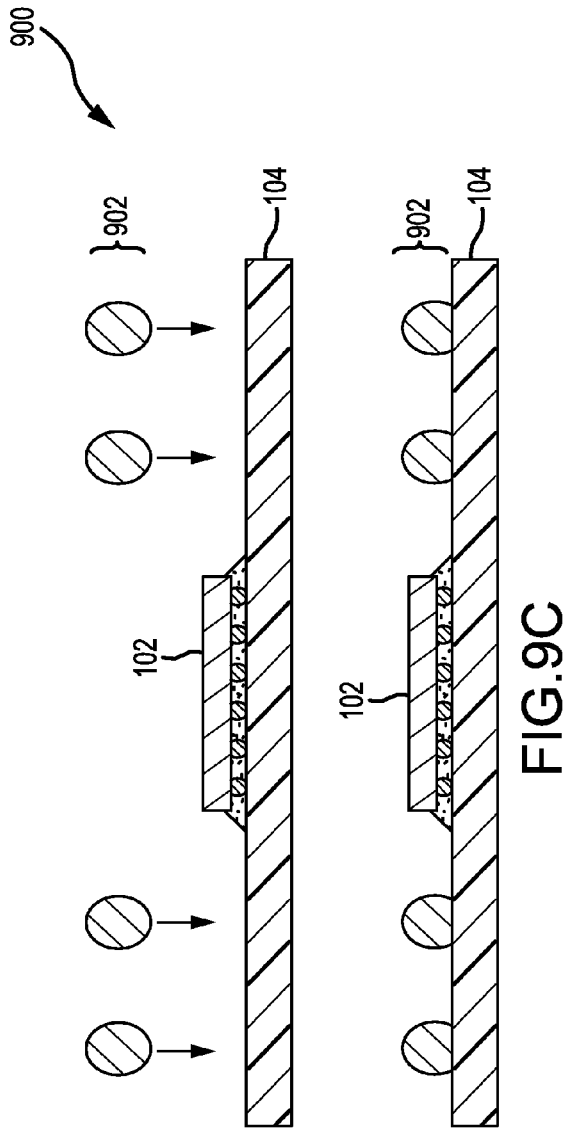


FIG.9C

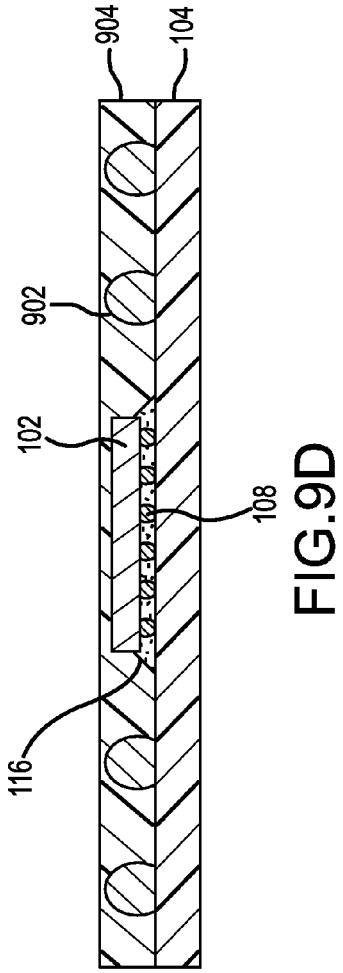


FIG.9D

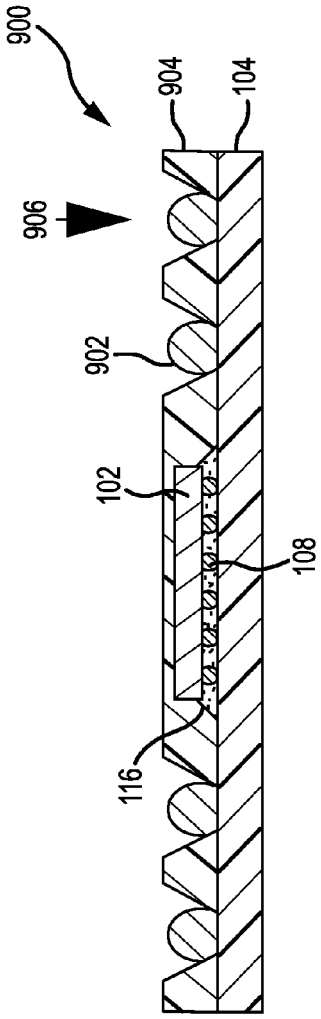


FIG.9E

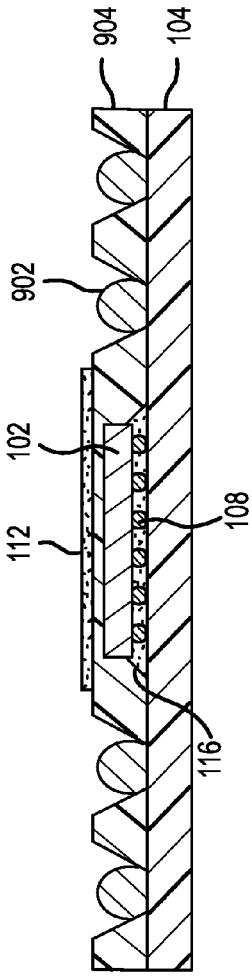
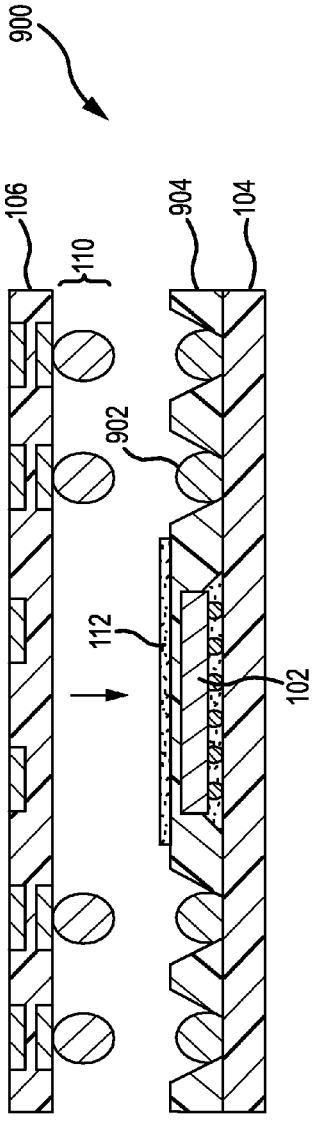
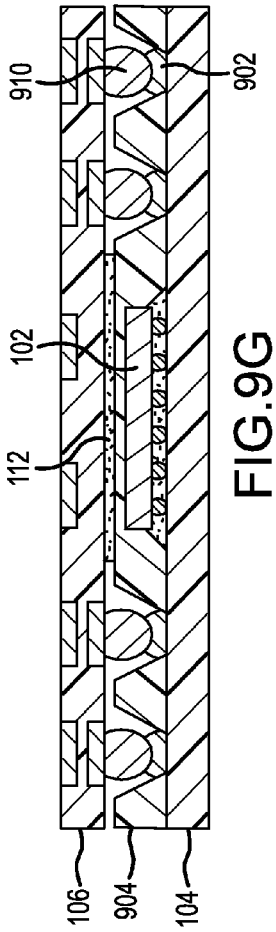


FIG.9F


900
106
110
904
104
902
112
102


910
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904
104

FIG.9G

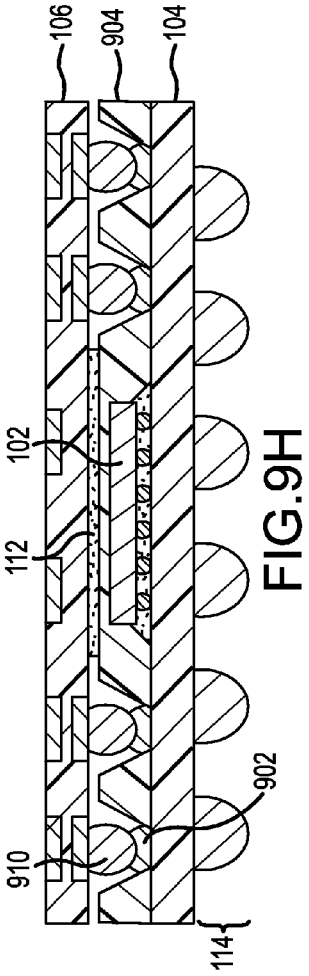
106
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FIG.9H

INTERPOSER PACKAGE-ON-PACKAGE STRUCTURE

CROSS-REFERENCE TO RELATED APPLICATIONS

The present application claims the benefit of U.S. Provisional Patent Application Ser. No. 61/876,684, titled "INTERPOSER PACKAGE-ON-PACKAGE STRUCTURE," filed on Sep. 11, 2013, which is hereby incorporated by reference in its entirety for all purposes.

TECHNICAL FIELD

The present description relates generally to integrated circuit packaging, and more particularly, but not exclusively, to flip chip packaging technology.

BACKGROUND

As mobile devices become more powerful and less power-consuming, integrated circuit packaging technologies are increasingly required to integrate a growing number of electrical components, such as discrete memories and radio frequency front-end components, into a single package solution with a smaller layout footprint and smaller package thickness. Several approaches in designing the integrated circuit packaging technologies have included flip-chip packaging. Flip-chip packaging offers short interconnections between a semiconductor chip and a corresponding substrate, supports multi-layer substrate technology for high-capacitance and low-inductance power delivery and provides efficient cooling mechanisms for heat to be dissipated from transistor junctions to surrounding environments.

BRIEF DESCRIPTION OF THE DRAWINGS

Certain features of the subject technology are set forth in the appended claims. However, for purpose of explanation, several embodiments of the subject technology are set forth in the following figures.

FIG. **1** illustrates a cross-sectional view of an integrated circuit package in accordance with one or more implementations of the subject technology.

FIGS. **2**A-**2**B illustrate cross-sectional views of examples of the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology.

FIG. **3** illustrates a cross-sectional view of an example of the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology.

FIG. **4** illustrates a cross-sectional view of an example of the integrated circuit package illustrated in FIG. **3** in accordance with one or more implementations of the subject technology.

FIGS. **5**A-**5**B illustrate an example of the integrated circuit package illustrated in FIG. **3** in accordance with one or more implementations of the subject technology, where FIG. **5**A illustrates a cross-sectional view of the integrated circuit package and FIG. **5**B illustrates a top view of a cross-section of the integrated circuit package along a B-B' axis.

FIGS. **6**A-**6**B illustrate cross-sectional views of examples of the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology.

FIGS. **7**A-**7**D illustrate top views of examples of an adhesive material included in the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology.

FIGS. **8**A-**8**F illustrate cross-sectional views of examples in manufacturing the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology.

FIGS. **9**A-**9**H illustrate cross-sectional views of examples in manufacturing the integrated circuit package illustrated in FIG. **3** in accordance with one or more implementations of the subject technology.

DETAILED DESCRIPTION

The detailed description set forth below is intended as a description of various configurations of the subject technology and is not intended to represent the only configurations in which the subject technology may be practiced. The appended drawings are incorporated herein and constitute a part of the detailed description. The detailed description includes specific details for the purpose of providing a thorough understanding of the subject technology. However, the subject technology is not limited to the specific details set forth herein and may be practiced using one or more implementations. In one or more instances, structures and components are shown in block diagram form in order to avoid obscuring the concepts of the subject technology.

In some approaches, an active die is embedded in a mold compound that is arranged between upper and base substrates with solder balls having a copper core to provide an interconnection between the upper and base substrates. However, this approach includes several shortcomings: (1) the mold compound arranged between the upper and base substrates is required to be assembled at the same time, (2) the total thickness between the substrates including the mold compound is increased, (3) the solder balls with the copper core are more expensive compared to standard solder balls and are more difficult in providing adequate solder with upper and base substrates, and (4) warpage of the upper and base substrates makes substrate stacking process using thinly coated copper core solder balls increasingly sensitive to process variations and can lead to high manufacturing yield loss.

In other approaches, the active die and an array of electrically conductive vias are mounted to a bottom substrate and encapsulated with mold compound. The conductive vias are exposed subsequently to provide electrical contact pads from top of the mold compound. An interposer substrate is attached to the exposed pads to complete the interconnection with the bottom substrate. An air gap exists between the top interposer substrate and a top surface of the mold compound. However, this approach includes several shortcomings: (1) warpage of the interposer substrate at reflow temperature that can be large thus causing solder joint opening, (2) the total thickness of the package with the interposer and mold compound is increased, and (3) the package requires a through-mold via process that increases assembly costs.

The subject disclosure provides an interposer enabled package-on-package (PoP) structure having a bare die flip chip. The PoP structure of the subject disclosure provides several advantages over conventional approaches including, but not limited to: (1) a low profile package PoP design, (2) reduction of electromagnetic interference (EMI) and providing EMI shielding, (3) thermal performance enhancement technologies for IC packages, (4) electrical performance enhancement technologies for IC packages, and (5) high speed communication applications. In addition, the PoP

structure of the subject disclosure is thinner compared to conventional approaches since the adhesive material has a thinner bond-line thickness than structures including a mold compound. Further, the cost of manufacturing is lower than conventional approaches since molding is not necessary and no copper core based solder balls are required.

In some aspects, an integrated circuit (IC) package includes an IC die having a first surface and a second surface opposite of the first surface. The IC package includes first contact members coupled to the second surface of the IC die. The IC package includes a bottom substrate having a first surface and a second surface with the second surface of the bottom substrate being opposite of the first surface of the bottom substrate, where the first surface of the bottom substrate is coupled to the second surface of the IC die via the first contact members. The IC package includes an interposer substrate coupled to the first surface of the IC die via an adhesive material, where the adhesive material is disposed on at least a portion of a surface of the interposer substrate. The IC package includes second contact members coupled along a periphery of the interposer substrate, where the interposer substrate is coupled to the first surface of the bottom substrate via the second contact members.

FIG. **1** illustrates a cross-sectional view of an integrated circuit package **100** in accordance with one or more implementations of the subject technology. Not all of the depicted components may be required, however, and one or more implementations may include additional components not shown in the figure. Variations in the arrangement and type of the components may be made without departing from the spirit or scope of the claims as set forth herein. Additional components, different components, or fewer components may be provided.

The integrated circuit (IC) package **100** includes IC die **102**, bottom substrate **104**, and interposer substrate **106**. The IC package **100** also includes first electrical contact members **108**, second electrical contact members **110**, adhesive material **112**, third electrical contact members **114**, and underfill material **116**. The integrated circuit package **100** may be a flip-chip device.

IC die **102**, bottom substrate **104** and interposer substrate **106** each have a first surface and a second surface opposite of the first surface. The second surface of IC die **102** includes first electrical contact members **108**. The second surface of IC die **102** is coupled to the first surface of bottom substrate **104** via first electrical contact members **108**. In this regard, IC die **102** is configured to make electrical contact with bottom substrate **104**.

The second surface of IC die **102** may be bonded to the first surface of bottom substrate **104** using underfill material **116**. The underfill material **116** may be disposed between the second surface of IC die **102** and the first surface of bottom substrate **104** such that underfill material **116** encapsulates the first electrical contact members **108** and the second surface of IC die **102**. The underfill material **116** can be configured to provide mechanical protection (e.g., reduce stress) of first electrical contact members **108**. The underfill material **116** may be a capillary underfill (CUF).

The first electrical contact members **108** include multiple conductive bumps (sometimes referred to as solder bumps) that are placed on (or mounted to) the second surface of IC die **102**. The second surface of IC die **102** is arranged to face downward and towards the first surface of bottom substrate **104**. The first electrical contact members **108** on the second surface of IC die **102** connect directly to bottom substrate **104**. The first electrical contact members **108** facilitate electrical connections from the second surface of IC die **102** to the first surface of bottom substrate **104**. The first electrical contact members **108** may be densely arranged onto IC die **102**. In some aspects, lead-free solder bumps (e.g., tin, silver, copper, tin/silver) as shown in FIG. **1** or copper pillars (not shown) can be used for first electrical contact members **108**.

In certain aspects, IC die **102** includes contact pads configured to receive first electrical contact members **108**. Because first electrical contact members **108** can be placed directly on the contact pads of the second surface of IC die **102**, the electrical interconnection path length from IC die **102** to bottom substrate **104** is substantially reduced. Consequently, the impedance of the electrical interconnection can be reduced substantially and higher speeds for signal transmission between IC die **102** and bottom substrate **104** can be realized.

The second surface of bottom substrate **104** includes third electrical contact members **114**. Here, a matrix of solder balls is mounted on the second surface (sometimes referred to as the bottom surface) of bottom substrate **104**. The third electrical contact members **114** may be attached to a bottom conductive layer of bottom substrate **104** to facilitate the electrical interconnections between bottom substrate **104** and an external printed circuit board (not shown). In some aspects, third electrical contact members **114** are arranged in a ball grid array on the bottom conductive layer of bottom substrate **104**. In comparison, third electrical contact members **114** are less densely arranged than first electrical contact members **108** on the second surface of IC die **102**. Each of first electrical contact members **108** on the second surface of IC die **102** is electrically connected to a corresponding one of third electrical contact members **114** through conductive segments in one or more layers in bottom substrate **104** and through one or more electrical vias between the one or more layers of bottom substrate **104**.

Interposer substrate **106** is coupled to the first surface of IC die **102** via adhesive material **112**. The adhesive material **112** is disposed on at least a portion of a surface (sometimes referred to as the bottom surface) of interposer substrate **106** to bond interposer substrate **106** to the second surface of IC die **102**. In this regard, the bond-line thickness can be minimized to approximately in a range of 10 to 20 micrometers (μm) to reduce the total package thickness. The adhesive material **112** can be suitable for a reflow process such that adhesive material **112** can be cured during the reflow process. The adhesive material **112** can be formulated to use a lead-free (Pb-free) solder reflow profile (e.g., temperature change history) for curing.

The interposer substrate **106** includes second electrical contact members **110**. The interposer substrate **106** is coupled to the first surface of bottom substrate via second electrical contact members **110**. In this regard, interposer substrate **106** and bottom substrate **104** are electrically connected through second electrical contact members **110**.

Interposer substrate **106** provides an interface structure for package-to-package vertical interconnection. Interposer substrate **106** includes a first surface (sometimes referred to as the top surface) that may include contact pads for interconnection with other surface mountable components such as Application Specific Integrated Circuits (ASICs) and discrete memory device packages including flip chip and wire bond BGAs, passive components such as capacitors, inductors, electromagnetic coupling baluns, electromagnetic radiators, and resistors. In this regard, the contact pads can be used to connect electronic components for package-to-package electrical interconnections such as package stacking to form PoP stack.

An advantage of the interposer enabled package-on-package (PoP) structure having the bare die flip chip illustrated in FIG. **1** is that the vertical interconnection length between bottom substrate **104** and interposer substrate **106** is substantially shorter than interconnections requiring a mold compound. The adhesive material **112** allows interposer substrate **106** to have a shorter distance to bottom substrate **104**. In this regard, interposer substrate **106** provides a low-impedance signal transmission path to IC die **102**. The interconnection path length reduction enables high speed communication between IC die **102** mounted on bottom substrate **104** and components (not shown) mounted on interposer substrate **106**. Consequently, high speed communication between the bottom substrate **104** and interposer substrate **106** can be achieved.

Because adhesive material **112** provides reinforcement of IC die **102** to the PoP structure, the footprint of the PoP structure can be minimized. In mobile applications such as cell phones, hand-held video and audio players, smaller footprint size of PoP structures can translate into smaller application devices.

FIGS. **2**A-**2**B illustrate cross-sectional views of examples of the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology. Not all of the depicted components may be required, however, and one or more implementations may include additional components not shown in the figure. Variations in the arrangement and type of the components may be made without departing from the spirit or scope of the claims as set forth herein. Additional components, different components, or fewer components may be provided.

Referring to FIG. **2**A, IC package **200** includes IC die **102**, bottom substrate **104**, and interposer substrate **106**. The IC package **200** also includes first electrical contact members **108**, second electrical contact members **110**, adhesive material **112**, third electrical contact members **114**, and underfill material **116**. IC package **200** also includes non-conductive adhesive material **202** and **204**. For example, non-conductive paste (NCP) formulated for solder reflow process can be used for **202** and **204**. Because IC package **200** is substantially similar to IC package **100** of FIG. **1**, only differences will be discussed with respect to FIG. **2**A.

Here, a non-conductive adhesive (e.g., **202** and **204**) is disposed on one or more portions of the first surface of bottom substrate **104** at a periphery of bottom substrate **104**. In some aspects, the periphery includes placement locations of second electrical contact members **110**. As such, the adhesive (e.g., **202** and **204**) encapsulates second electrical contact members **110**.

The surface (e.g., the bottom surface) of interposer substrate **106** makes contact with **202** and **204**. Adhesive **202** and **204** may be employed to mechanically bond interposer substrate **106** with bottom substrate **104**. In some aspects, adhesive **202** and **204** is inserted between second electrical contact members **110** with interposer substrate **106** coupled to bottom substrate **104** to provide further reinforcement. The non-conductive adhesive may include an epoxy material. The adhesive material **112** may be formed of a same material as the NCP compound.

Referring to FIG. **2**B, IC package **250** includes IC die **102**, bottom substrate **104**, and interposer substrate **106**. IC package **250** also includes first electrical contact members **108**, second electrical contact members **110**, adhesive material **112**, third electrical contact members **114**, and underfill material **116**. IC package **250** also includes non-conductive adhesive **204**. Because IC package **250** is substantially similar to IC package **200** of FIG. **2**A, only differences will be discussed with respect to FIG. **2**B.

Here, adhesive **204** is disposed on a portion of the first surface of bottom substrate **104** that is at the periphery of bottom substrate **104**. Adhesive **204** may be inserted between a subset of second electrical contact members **110** to provide further reinforcement at the specified portion of IC package **250**.

FIG. **3** illustrates a cross-sectional view of an example of the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology. Not all of the depicted components may be required, however, and one or more implementations may include additional components not shown in the figure. Variations in the arrangement and type of the components may be made without departing from the spirit or scope of the claims as set forth herein. Additional components, different components, or fewer components may be provided.

IC package **300** includes IC die **102**, bottom substrate **104**, and interposer substrate **106**. The IC package **300** also includes first electrical contact members **108**, second electrical contact members **110**, adhesive material **112**, third electrical contact members **114**, and underfill material **116**. IC package **300** also includes mold compound **302**. Because IC package **300** is substantially similar to IC package **100** of FIG. **1**, only differences will be discussed with respect to FIG. **3**.

Here, IC package **300** includes mold compound **302** disposed on the first surface of bottom substrate **104** with second electrical contact members extending above a surface (sometimes referred to as a top surface) of mold compound **302**. In some aspects, mold compound **302** encapsulates IC die **102**. The top surface of mold compound **302** can be drilled, milled, etched, and/or irradiated with a laser beam to remove material of mold compound **302** to form openings and partially expose second electrical contact members **110**.

As shown in FIG. **3**, adhesive material **112** is disposed on the surface of mold compound **302**. As such, the interposer substrate **106** is coupled to the surface of mold compound **302** via adhesive material **112**. The adhesive material **112** is disposed where an air gap is present between the top surface of mold compound **302** and the bottom surface of interposer substrate **106**. The air gap may be in a range of 3 micrometers (μm) up to 30 μm.

FIG. **4** illustrates a cross-sectional view of an example of the integrated circuit package illustrated in FIG. **3** in accordance with one or more implementations of the subject technology. Not all of the depicted components may be required, however, and one or more implementations may include additional components not shown in the figure. Variations in the arrangement and type of the components may be made without departing from the spirit or scope of the claims as set forth herein. Additional components, different components, or fewer components may be provided.

IC package **400** includes IC die **102**, bottom substrate **104**, and interposer substrate **106**. The IC package **400** also includes first electrical contact members **108**, second electrical contact members **110**, adhesive material **112**, third electrical contact members **114**, and underfill material **116**. IC package **400** also includes mold compound **302**. Because IC package **400** is substantially similar to IC package **300** of FIG. **3**, only differences will be discussed with respect to FIG. **4**.

Here, IC package **300** includes mold compound **302** disposed on the first surface of bottom substrate **104** with second electrical contact members **110** extending above a surface

(sometimes referred to as a top surface) of mold compound **302**. In some aspects, mold compound **302** partially encapsulates IC die **102**.

As shown in FIG. **4**, adhesive material **112** is disposed on the surface of mold compound **302** including the first surface of IC die **102**. As such, the interposer substrate **106** is coupled to the first surface of IC die **102** via adhesive material **112**. In some aspects, interposer substrate **106** is coupled to the surface of mold compound **302** and the first surface of IC die **102** via adhesive material **112**. The adhesive material **112** is disposed where an air gap is present between the top surface of mold compound **302** and the bottom surface of interposer substrate **106**. In some aspects, film assisted molding (FAM) technology is dispensed to cover the first surface of IC die **102**.

FIGS. **5**A-**5**B illustrate an example of the integrated circuit package illustrated in FIG. **3** in accordance with one or more implementations of the subject technology. Not all of the depicted components may be required, however, and one or more implementations may include additional components not shown in the figure. Variations in the arrangement and type of the components may be made without departing from the spirit or scope of the claims as set forth herein. Additional components, different components, or fewer components may be provided.

FIG. **5**A illustrates a cross-sectional view of IC package **500**. IC package **500** includes IC die **102**, bottom substrate **104**, and interposer substrate **106**. The IC package **500** also includes first electrical contact members **108**, second electrical contact members **110**, adhesive material **112**, third electrical contact members **114**, and underfill material **116**. IC package **500** also includes mold compound **302**. Because IC package **500** is substantially similar to IC package **300** of FIG. **3**, only differences will be discussed with respect to FIG. **5**A.

Here, adhesive material **112** is disposed at corner locations on the surface of mold compound **302**. In this respect, individual structures of adhesive material **112** are placed at respective corner locations. In some aspects, adhesive material **112** is disposed on the corner locations including additional locations between the corner locations on the periphery of mold compound **302**. The adhesive material **112** may be disposed as continuous or sectional structure (not shown) on the outer periphery (e.g., outer side of second electrical contact members **110**) of mold compound **302**.

FIG. **5**B illustrates an exemplary top view of a cross-section of IC package **500** along a B-B' axis. Here, adhesive material **112** is provided as individual structures **502***a*, **502***b*, **502***c* and **502***d* to provide reinforcement of IC package **500** at the corner locations with minimal amount of adhesive material needed to achieve a thinner PoP structure. The amount of adhesive material **112** needed to create contact between interposer substrate **106** and bottom substrate **104** may be be equivalent to the product of the height of the air gap formed between the substrates and the surface area of the respective corner location.

FIGS. **6**A-**6**B illustrate cross-sectional views of examples of the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology. Not all of the depicted components may be required, however, and one or more implementations may include additional components not shown in the figure. Variations in the arrangement and type of the components may be made without departing from the spirit or scope of the claims as set forth herein. Additional components, different components, or fewer components may be provided.

Referring to FIG. **6**A, IC package **600** includes IC die **102**, bottom substrate **104**, and interposer substrate **106**. The IC package **600** also includes first electrical contact members **108**, second electrical contact members **110**, adhesive material **602***a* and **602***b*, third electrical contact members **114**, and underfill material **116**. Because IC package **600** is substantially similar to IC package **100** of FIG. **1**, only differences will be discussed with respect to FIG. **6**A.

As shown in FIG. **6**A, adhesive material **602***a* and **602***b* are disposed at multiple locations on the first surface of IC die **102**. In this respect, there is an air gap formed between the disposed portions of adhesive material **602***a* and **602***b*. The adhesive material **602***a* and **602***b* may include different patterns, including but not limited to, square-shaped structures, rectangular-shaped structures or circle-shaped structures at each location on the second surface of IC die **102**.

Referring to FIG. **6**B, adhesive material **604** is disposed on a portion of the first surface of IC die **102**. In this respect, adhesive material **604** bonds the portion of the first surface of IC die **102** to interposer substrate **106**.

FIGS. **7**A-**7**D illustrate top views of examples of an adhesive material included in the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology. Not all of the depicted components may be required, however, and one or more implementations may include additional components not shown in the figure. Variations in the arrangement and type of the components may be made without departing from the spirit or scope of the claims as set forth herein. Additional components, different components, or fewer components may be provided.

Adhesive material **112** may be dispensed in different patterns as illustrated by FIGS. **7**A-**7**D. Referring to FIG. **7**A, adhesive material **112** has a pattern that includes multiple intersecting cross-shaped structures. The cross-shaped structures can include different sizes. In this regard, adhesive material **112** is disposed at a center location on the bottom surface of interposer substrate **106** or first surface of IC die **102** depending on implementation.

Referring to FIG. **7**B, adhesive material **112** has a pattern that includes multiple linear-shaped structures in a circular arrangement. In this regard, adhesive material **112** is deposited at a center location on the bottom surface of interposer substrate **106** or first surface of IC die **102** depending on implementation.

Referring to FIG. **7**C, adhesive material **112** has a pattern that includes a plurality of circular-shape structures. In this regard, adhesive material **112** is disposed at corner locations on the first surface of IC die **102** with one circular-shaped structure at a respective corner location. Alternatively, adhesive material **112** can be disposed at corresponding locations of the bottom surface of interposer substrate **106**.

Referring to FIG. **7**D, adhesive material **112** has a pattern that includes a circular-shaped structure. In this regard, adhesive material **112** is disposed at a center location of interposer substrate **106** or IC die **102**. The different patterns for adhesive material **112** as discussed with regard to FIGS. **7**A-**7**D are applicable to the IC package of FIG. **3**.

FIGS. **8**A-**8**F illustrate cross-sectional views of examples in manufacturing the integrated circuit package illustrated in FIG. **1** in accordance with one or more implementations of the subject technology. Although method **800** is described herein with reference to the examples of FIGS. **8**A-**8**F, method **800** is not limited to these examples. Furthermore, although method **800** is illustrated in the order shown in FIGS. **8**A-**8**F, it is understood that method **800** may be implemented in a different order.

Referring to FIG. **8**A, method **800** includes a process for coupling first electrical contact members **110** to a first surface of interposer substrate **106**. In this regard, first electrical contact members are coupled to a bottom surface (e.g., surface facing down toward IC die **102**) of interposer substrate **106**. In some aspects, contact pads may be mounted to the first and second surfaces of interposer substrate **106**. In this respect, external components can be coupled to the second surface (e.g., top surface) for electrical interconnection with IC die **102**.

Referring to FIG. **8**B, method **800** includes a process for mounting a first surface of an IC die to a first surface of bottom substrate **104**. The IC die **102** includes second electrical contact members **108**. In some aspects, method **800** includes a sub-process for mounting second electrical contact members **108** to the first surface of IC die **102**. The second electrical contact members **108** can include solder balls, conductive posts such as copper pillars or conductive landing pins.

Referring to FIG. **8**C, method **800** includes a process for disposing underfill material **116** between the first surface of IC die **102** and the first surface of bottom substrate **104**. In this regard, the underfill material **116** can be non-conductive paste material that encapsulates second electrical contact members **108**. The underfill material **116** can be inserted within second electrical contact members **108** with IC die **102** coupled to the first surface of bottom substrate **104**.

Referring to FIG. **8**D, method **800** includes a process for dispensing adhesive material **112** to a second surface of IC die **102**. Here, adhesive material **112** is applied on the entire second surface (or backside surface) of IC die **102**. As described above, adhesive material **112** can be applied (or dispensed) onto one or more portions of the second surface of IC die **102**. The adhesive material **112** provides reinforcement between IC die **102** and interposer substrate **106**, which provides for a low PoP structure profile.

Referring to FIG. **8**E, method **800** includes a process for coupling the surface of interposer substrate **106** to the first surface of bottom substrate **104**. Here, the second surface of IC die **102** is bonded to at least a portion of the surface of interposer substrate **106** via adhesive material **112**. Method **800** includes a process for applying a reflow process with a reflow temperature to at least cure adhesive material **112**.

Referring to FIG. **8**F, method **800** includes a process for coupling third electrical contact members **114** to a second surface of bottom substrate **104** (e.g., opposite of the first surface of bottom substrate **104**). Here, first electrical contact members **110** are electrically connected to third electrical contact members **114** through bottom substrate **104**.

FIGS. **9**A-**9**H illustrate cross-sectional views of examples in manufacturing the integrated circuit package illustrated in FIG. **3** in accordance with one or more implementations of the subject technology. Although method **900** is described herein with reference to the examples of FIGS. **9**A-**9**H, method **900** is not limited to these examples. Furthermore, although method **900** is illustrated in the order shown in FIGS. **9**A-**9**H, it is understood that method **900** may be implemented in a different order. Because method **900** is substantially similar to method **800** of FIGS. **8**A-**8**F, only differences will be discussed with respect to FIGS. **9**A-**9**H.

Referring to FIG. **9**A, method **900** includes a process for coupling first electrical contact members **110** to a first surface of interposer substrate **106**. Referring to FIG. **9**B, method **900** includes a process for mounting a first surface of an IC die to a first surface of bottom substrate **104**. The IC die **102** includes second electrical contact members **108**. In some aspects, method **900** includes a sub-process for mounting second electrical contact members **108** to the first surface of IC die **102**. The second electrical contact members **108** can include solder balls, conductive posts or conductive landing pins.

Referring to FIG. **9**C, method **900** includes a process for coupling fourth electrical contact members **902** to the first surface of bottom substrate **104**. The fourth electrical contact members **902** can include lead-free solder balls.

Referring to FIG. **9**D, method **900** includes a process for disposing mold compound **904** to the first surface of bottom substrate **104**. Here, mold compound **904** encapsulates fourth electrical contact members **902**.

Referring to FIG. **9**E, method **900** includes a process for applying a laser ablation process **906** to mold compound **302**. The laser ablation process may include removing material from mold compound **904** by applying a laser beam to the top surface of mold compound **904**. As such, the laser beam irradiates the top surface to create openings or trenches to expose fourth electrical contact members **902**. In this regard, one or more portions at the top surface of mold compound **904** located directly above fourth electrical contact members **902** are removed by laser ablation process **906**. Other methods, such as mechanical drilling or chemical etching can be used to expose fourth electrical contact members **902**.

Referring to FIG. **9**F, method **900** includes a process for disposing adhesive material **112** on at least a portion of the surface of mold compound **904**. In this respect, the portion of the surface of mold compound **904** disposed with **112** adhesive material is bonded to the surface of interposer substrate **106**. The adhesive material **112** can be applied (or dispensed) on one or more portions of mold compound **904** to provide one or more adhesive material structures.

Referring to FIG. **9**G, method **900** includes a process for coupling first electrical contact members **110** to fourth electrical contact members **902**. In some aspects, first electrical contact members **110** are aligned with fourth electrical contact members **902**. Method **900** also includes a sub-process for applying a reflow process to facilitate the coupling of the electrical contact members. In certain implementations, first electrical contact members **110** are infused with fourth electrical contact members **902** during the reflow process to form infused electrical contact members **910**. The reflow process may be employed to cure adhesive material **112** to provide a mechanical bonding between mold compound **904** and interposer substrate **106**.

Referring to FIG. **9**H, method **900** includes a process for coupling third electrical contact members **114** to a second surface of bottom substrate **104** (e.g., opposite of the first surface of bottom substrate **104**). Here, infused electrical contact members **910** are electrically connected to third electrical contact members **114** through bottom substrate **104**.

As used herein, the phrase "at least one of" preceding a series of items, with the term "and" or "or" to separate any of the items, modifies the list as a whole, rather than each member of the list (i.e., each item). The phrase "at least one of" does not require selection of at least one of each item listed; rather, the phrase allows a meaning that includes at least one of any one of the items, and/or at least one of any combination of the items, and/or at least one of each of the items. By way of example, the phrases "at least one of A, B, and C" or "at least one of A, B, or C" each refer to only A, only B, or only C; any combination of A, B, and C; and/or at least one of each of A, B, and C.

Phrases such as an aspect, the aspect, another aspect, some aspects, one or more aspects, an implementation, the implementation, another implementation, some implementations, one or more implementations, an embodiment, the embodiment, another embodiment, some embodiments, one or more

embodiments, a configuration, the configuration, another configuration, some configurations, one or more configurations, the subject technology, the disclosure, the present disclosure, other variations thereof and alike are for convenience and do not imply that a disclosure relating to such phrase(s) is essential to the subject technology or that such disclosure applies to all configurations of the subject technology. A disclosure relating to such phrase(s) may apply to all configurations, or one or more configurations. A disclosure relating to such phrase(s) may provide one or more examples. A phrase such as an aspect or some aspects may refer to one or more aspects and vice versa, and this applies similarly to other foregoing phrases.

The word "exemplary" is used herein to mean "serving as an example, instance, or illustration." Any embodiment described herein as "exemplary" or as an "example" is not necessarily to be construed as preferred or advantageous over other embodiments. Furthermore, to the extent that the term "include," "have," or the like is used in the description or the claims, such term is intended to be inclusive in a manner similar to the term "comprise" as "comprise" is interpreted when employed as a transitional word in a claim.

Furthermore, it should be understood that spatial descriptions (e.g., "above", "below", "left," "right," "up", "down", "top", "bottom", etc.) used herein are for purposes of illustration only, and that practical implementations of the structures described herein can be spatially arranged in any orientation or manner.

All structural and functional equivalents to the elements of the various aspects described throughout this disclosure that are known or later come to be known to those of ordinary skill in the art are expressly incorporated herein by reference and are intended to be encompassed by the claims. Moreover, nothing disclosed herein is intended to be dedicated to the public regardless of whether such disclosure is explicitly recited in the claims. No claim element is to be construed under the provisions of 35 U.S.C. §112, sixth paragraph, unless the element is expressly recited using the phrase "means for" or, in the case of a method claim, the element is recited using the phrase "step for."

The previous description is provided to enable any person skilled in the art to practice the various aspects described herein. Various modifications to these aspects will be readily apparent to those skilled in the art, and the generic principles defined herein may be applied to other aspects. Thus, the claims are not intended to be limited to the aspects shown herein, but are to be accorded the full scope consistent with the language claims, wherein reference to an element in the singular is not intended to mean "one and only one" unless specifically so stated, but rather "one or more." Unless specifically stated otherwise, the term "some" refers to one or more. Pronouns in the masculine (e.g., his) include the feminine and neuter gender (e.g., her and its) and vice versa. Headings and subheadings, if any, are used for convenience only and do not limit the subject disclosure.

What is claimed is:

1. An integrated circuit (IC) package comprising:

an IC die having a first surface and a second surface opposite of the first surface, wherein the second surface of the IC die includes a first plurality of electrical contact members;

a bottom substrate having a first surface and a second surface, the second surface of the bottom substrate being opposite of the first surface of the bottom substrate, wherein the first surface of the bottom substrate is coupled to the IC die via the first plurality of electrical contact members, wherein the second surface of the bottom substrate includes a second plurality of electrical contact members; and

an interposer substrate coupled to the first surface of the IC die via an adhesive material, wherein the adhesive material is disposed at a plurality of locations on a surface of the interposer substrate and the first surface of the IC die, wherein the interposer substrate includes a third plurality of electrical contact members, wherein the interposer substrate is coupled to the first surface of the bottom substrate via the third plurality of electrical contact members.

2. The IC package of claim **1**, wherein the IC die is a flip chip die.

3. The IC package of claim **1**, further comprising a non-conductive adhesive disposed on one or more portions of the first surface of the bottom substrate at a periphery of the bottom substrate, wherein the surface of the interposer substrate makes contact with the non-conductive adhesive, and wherein the non-conductive adhesive at least partially encapsulates the second plurality of electrical contact members.

4. The IC package of claim **1**, further comprising a mold compound disposed on the first surface of the bottom substrate, wherein the second plurality of electrical contact members extend above a surface of the mold compound.

5. The IC package of claim **4**, wherein the interposer substrate is coupled to the surface of the mold compound via the adhesive material, wherein the adhesive material is disposed where an air gap is present between the surface of the mold compound and the surface of the interposer substrate, and wherein the mold compound encapsulates the IC die.

6. The IC package of claim **4**, wherein the mold compound partially encapsulates the IC die, and wherein the adhesive material is disposed where an air gap is present between the surface of the mold compound and the surface of the interposer substrate.

7. The IC package of claim **6**, wherein the interposer substrate is coupled to the first surface of the IC die via the adhesive material.

8. The IC package of claim **6**, wherein the interposer substrate is coupled to the surface of the mold compound and the first surface of the IC die via the adhesive material.

9. The IC package of claim **4**, wherein the adhesive material is disposed at corner locations on the surface of the mold compound.

10. The IC package of claim **1**, wherein the adhesive material has a pattern that includes a plurality of intersecting cross-shaped structures, and wherein the adhesive material is disposed at a center location of the first surface of the IC die or corresponding location on the interposer substrate.

11. The IC package of claim **1**, wherein the adhesive material has a pattern that includes a plurality of linear-shaped structure in a circular arrangement, and wherein the adhesive material is disposed at a center location of the first surface of the IC die or corresponding location on the interposer substrate.

12. The IC package of claim **1**, wherein the adhesive material has a pattern that includes a plurality of circular-shape structures, and wherein the adhesive material is disposed at corner locations of the first surface of IC die or corresponding location on the interposer substrate with one circular-shaped structure at a respective corner location.

13. The IC package of claim **1**, wherein the adhesive material has a pattern that includes a circular-shaped structure, and wherein the adhesive material is disposed at a center location of the first surface of IC die or corresponding location on the interposer substrate.

14. The IC package of claim 1, wherein the adhesive material is disposed at corner locations on the first surface of the IC die.

15. The IC package of claim 1, wherein the adhesive material is disposed on a portion of the first surface of the IC die.

16. A method of manufacturing an integrated circuit (IC) package, the method comprising:

coupling a first plurality of electrical contact members to a surface of an interposer substrate;

mounting a first surface of an IC die to a first surface of a bottom substrate, wherein the IC die includes a second plurality of electrical contact members;

disposing an underfill compound between the first surface of the IC die and the first surface of the bottom substrate, wherein the underfill compound is embedded within the second plurality of electrical contact members;

disposing an adhesive material at a plurality of locations on a second surface of the IC die;

coupling the surface of the interposer substrate to the first surface of the bottom substrate, wherein the second surface of the IC die is bonded to at least a portion of the surface of the interposer substrate via the adhesive material; and

coupling a third plurality of electrical contact members to a second surface of the bottom substrate opposite of the first surface of the bottom substrate.

17. The method of claim 16, wherein coupling the surface of the interposer substrate to the first surface of the bottom substrate comprises applying a reflow process with a reflow temperature to at least cure the adhesive material.

18. The method of claim 17, further comprising coupling a fourth plurality of electrical contact members to the first surface of the bottom substrate.

19. The method of claim 18, further comprising disposing a mold compound to the first surface of the bottom substrate, wherein the mold compound encapsulates the fourth plurality of electrical contact members.

20. The method of claim 19, further comprising applying a laser ablation process to the mold compound, wherein portions at a surface of the mold compound directly above the fourth plurality of electrical contact members are removed by the laser ablation process, and wherein the adhesive material is disposed on at least a portion of the surface of the mold compound.

21. The method of claim 20, wherein coupling the surface of the interposer substrate to the first surface of the bottom substrate comprises coupling the first plurality of electrical contact members to the fourth plurality of electrical contact members, wherein the first plurality of electrical contact members are aligned with the fourth plurality of electrical contact members, and wherein the portion of the surface of the mold compound disposed with the adhesive material is bonded to the surface of the interposer substrate.

22. An integrated circuit (IC) package comprising:

an IC die having a first surface and a second surface opposite of the first surface, wherein the second surface of the IC die includes a first plurality of electrical contact members;

a bottom substrate having a first surface and a second surface, the second surface of the bottom substrate being opposite of the first surface of the bottom substrate, wherein the first surface of the bottom substrate is coupled to the IC die via the first plurality of electrical contact members, wherein the second surface of the bottom substrate includes a second plurality of electrical contact members;

a mold compound disposed on the first surface of the bottom substrate, wherein a third plurality of electrical contact members extend above a top surface of the mold compound; and

an interposer substrate coupled to the top surface of the mold compound via an adhesive material, wherein the adhesive material is disposed at a plurality of locations on a surface of the interposer substrate and the top surface of the mold compound, wherein the interposer substrate includes the third plurality of electrical contact members, wherein the interposer substrate is coupled to the first surface of the bottom substrate via the third plurality of electrical contact members.

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